

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 Applicants: Jen-Chau Wu et al.

Appl. No.: 10/791,709 Filing Date: 03/04/2004

Examiner: PHAM, LONG Art Unit: 2814

Docket No.: UECP0012USA

10 Title: ESD PROTECTION CONFIGURATION AND METHOD FOR
LIGHT EMITTING DIODES

To: Commissioner for Patents
P.O. Box 1450

15 Alexandria VA 22313-1450

Subject: Affidavit of Cheng-Chung Yang

Dear Sir,

Cheng-Chung Yang, being duly sworn, deposes and says as
20 follows:

1. I, Cheng-Chung Yang, am an employee of the firm of United
Epitaxy Company, LTD, and responsible for invention.

2. I am one of the joint inventors of the patent application
entitled: ESD PROTECTION CONFIGURATION AND METHOD FOR LIGHT
25 EMITTING DIODES, Serial No. 10/791,709, filed 03/04/2004.

I used Cheng-Chung Yung as my name when signed the documents



of the COMBINED DECLARATION AND POWER OF ATTORNEY and
ASSIGNMENT OF INVENTION on that time.

3. However, I noticed that the transliteration of my name
on passport is Cheng-Chung Yang after the application filed.

5 In order to get enough protection of right, I decided to
correct my name used in the aforesaid documents from
Cheng-Chung Young to Cheng-Chung Yang.

4. Please find a copy of my passport as enclosed to prove
Cheng-Chung Young and Cheng-Chung Yang are one and the same
10 person and that person is me.

IN WITNESS WHEREOF, I have hereunto set my hand and affixed
my seal th _____ day of _____, 2004.

✓ *Cheng Chung Yang* *Cheng Chung Yang*
Cheng-Chung Yang Cheng-Chung Young
 

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